| | Hits | Search Text | DBs | Time Stamp |
|---|------|---|----------------|---------------------|
| 1 | 9 | (chamber and substrate and titanium and ((physical adj vapor adj deposition) PvD) and hydrogen).clm. | US-PGPUB | 2005/11/23 17:15 |
| 2 | 28 | (chamber and substrate and titanium and sputter\$3 and hydrogen).clm. | 1110 - 0(20110 | 2005/11/23 17:15 |
| 3 | 8 | (chamber and substrate and titanium and ((physical adj vapor adj deposition) PvD) and hydrogen and plasma).clm. | ILIC - DESDITE | 2005/11/23 17:16 |
| 4 | 24 | (chamber and substrate and titanium and sputter\$3 and hydrogen and gas).clm. | IUS - PGPHR | 2005/11/23 17:15 |
| 5 | 2 | (chamber with substrate and titanium with ((physical adj vapor adj deposition) PvD) and hydrogen).clm. | IIS - PGPIIR | 2005/11/23 17:15 |
| 6 | 5 | (chamber with substrate and titanium with sputter\$3 and hydrogen).clm. | US-PGPUB | 2005/11/23 17:16 |
| 7 | 5 | (chamber with substrate and titanium with sputter\$3 and hydrogen and gas).clm. | IIG - DCDIIB | 2005/11/23 17:16 |
| 8 | 2 | (chamber with substrate and titanium with ((physical adj vapor adj deposition) PvD) and hydrogen and plasma).clm. | IIS-DCDIIB | 2005/11/23 17:16 |